

## Sensors and Microsystem Electronics (E030940)

**Course size** (nominal values; actual values may depend on programme)  
**Credits** 6.0      **Study time** 180 h      **Contact hrs** 60.0 h

**Course offerings and teaching methods in academic year 2017-2018**

B (semester 2)	group work	1.25 h
	practicum	15.0 h
	project	16.25 h
	guided self-study	27.5 h
A (semester 2)	lecture	27.5 h
	group work	1.25 h
	practicum	15.0 h
	project	16.25 h

**Lecturers in academic year 2017-2018**

De Smet, Herbert      TW06      lecturer-in-charge

**Offered in the following programmes in 2017-2018**

	crdts	offering
<a href="#">Bridging Programme European Master of Science in Photonics</a>	6	A
<a href="#">Bridging Programme Master of Science in Photonics Engineering</a>	6	A
<a href="#">Master of Science in Electrical Engineering (main subject Communication and Information Technology )</a>	6	A
<a href="#">Master of Science in Electromechanical Engineering (main subject Control Engineering and Automation)</a>	6	A
<a href="#">Master of Science in Electromechanical Engineering (main subject Electrical Power Engineering)</a>	6	A
<a href="#">Master of Science in Electrical Engineering (main subject Electronic Circuits and Systems)</a>	6	A
<a href="#">Master of Science in Electromechanical Engineering (main subject Maritime Engineering)</a>	6	A
<a href="#">Master of Science in Electromechanical Engineering (main subject Mechanical Construction)</a>	6	A
<a href="#">Master of Science in Electromechanical Engineering (main subject Mechanical Energy Engineering)</a>	6	A
<a href="#">European Master of Science in Photonics</a>	6	A
<a href="#">Master of Science in Photonics Engineering</a>	6	B

**Teaching languages**

Dutch, English

**Keywords**

sensors, actuators, calibration, signal conditioning, linearisation, microcontroller, interfacing, digital & analog transmission, LCOS microdisplay, PON receiver, LEDs

**Position of the course**

This compulsory course in the Photonics curriculum teaches the student the necessary skills for the electronic and opto-electronic interfacing of microsystems, including the use of sensors and actuators. This comprises transistor circuits, opamp circuits as well as microcontroller-based solutions, with hands-on experience.

## Contents

- Sensors and actuators: Types of sensors and actuators, Calibration, signal conditioning and alinearisation
- Electronic interfacing of sensors and actuators: Transistor circuits, Microcontroller concepts, Interfacing with PCs using IO cards, Matrix addressing and readout (microdisplays, imaging sensors)
- Electronic transmission of data: Analog transmission, Digital transmission, (eliminating) Interferences
- Microsystems, practice examples: Systems using basic components, Integrated Circuit systems (e.g. RFID tag, PON receiver chip), Systems based on existing modules/components, Systems exhibiting strong opto-electronic interaction (microdisplays, CCD&CMOS imaging chips, power-LEDs)

## Initial competences

Good basic knowledge of analog electronics and device physics.

## Final competences

- 1 Understand and describe the operation of electromotive, resistive, capacitive, inductive and primary sensors and actuators
- 2 Define and explain notions such as linearity, calibration, noise, precision, sensitivity and other sensor characteristics; Derive and comment on linearisation, bridge operation and differential ('push-pull') operation
- 3 Using sensors and actuators in practical applications, including the consulting of datasheets, the use of instrumentation software, the implementation of hardware (PC-) interfacing and dealing with electromagnetic interferences and other limitations of data transmission in a mature way
- 4 Deal with solid-state lights sources in an energy efficient way and take into account etendue limitations and electronic driving efficiency
- 5 Recognizing and explaining basic electronic circuits useful for sensor interfacing
- 6 Explain and discuss the operation and construction of the microsystems that were treated during the case studies.

## Conditions for credit contract

Access to this course unit via a credit contract is determined after successful competences assessment

## Conditions for exam contract

This course unit cannot be taken via an exam contract

## Teaching methods

Guided self-study, group work, lecture, practicum, project

## Learning materials and price

- syllabus (English, about 225 pages, sold through student organisation VTK)
- viewfoils (English; distributed for free via Minerva)

## References

- [1] J. Fraden, "Handbook of Modern Sensors" (AIP)
- [2] R. Pallàs-Areny / John Webster, "Sensors and signal conditioning" (Wiley and Sons)
- [3] Ilene J. Busch-Vishniac, "Electromechanical Sensors and Actuators"
- [4] Georges Asch, "Les Capteurs en Instrumentation Industrielle"
- [5] John P. Bentley, "Principles of Measurement Systems"
- [6] P. Rai-Choudhury, "Handbook of Microlithography, Micromachining and Microfabrication, Volume 2"
- [7] Aldert Van Der Ziel, "Noise", Prentice-Hall
- [8] D.V. Bugg, "Circuits, Amplifiers and Gates", Adam Hilger
- [9] James J. Allen, "Micro Electro Mechanical System Design", Taylor & Francis (Available via "EngNetBase")

## Course content-related study coaching

Interactive support via Minerva (forums, e-mail).

## Evaluation methods

end-of-term evaluation and continuous assessment

## Examination methods in case of periodic evaluation during the first examination period

Oral examination

## Examination methods in case of periodic evaluation during the second examination period

Oral examination

**Examination methods in case of permanent evaluation**

Skills test, report

**Possibilities of retake in case of permanent evaluation**

examination during the second examination period is possible in modified form

**Extra information on the examination methods**

During examination period: oral closed-book exam, written preparation. During semester: graded project reports; graded lab sessions; graded homework. Frequency: 3 lab exercises + 2 projects + 1 homework.

**Calculation of the examination mark**

Special conditions: lab exercises + projects + homework: 1/3%. examination: 2/3%.